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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Tadashi WATANABE et al.**

Group Art Unit: **2818**

Application Number: **10/823,729**

Examiner: **David Vu**

Filed: **April 14, 2004**

Confirmation Number: **5344**

For: **SEMICONDUCTOR DEVICE FABRICATION METHOD**

Attorney Docket Number: **042341**

Customer Number: **38834**

AMENDMENT UNDER 37 C.F.R. §1.111

MAIL STOP Amendment

Commissioner for Patents

P. O. Box 1450

Alexandria, VA 22313-1450

April 13, 2007

Sir:

In response to the Office Action dated January 22, 2007, Applicants amend the claims as follows and submit the following remarks.

Amendments to the Claims begin on page **2** of this paper.

Remarks/Arguments begin on page **13** of this paper.